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| Date: | October 15, 2003 | Fax: | 703-872-9310 |
| To: | U.S. Patent and Trademark Office | Phone: | 703-306-5665 |

Technology Center 1700 Fax Center - Before Final

| | |
|--------------------|-----------------------------------|
| From: | Carmen C. Cook |
| Serial No.: | 09/902,931 |
| Docket: | M-11706 US (NTG-P101) |
| Re: | Response to Office Action |
| Pages: | 11 (including cover sheet) |

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Message:

Re: Applicant(s): Kirk Martin
Assignee: Nisene Technology Group
Title: Method and Apparatus for Etching a Semiconductor Die
Serial No.: 09/902,931
Examiner: Vinh, Lan
Docket No.: M-11706 US
(NTG-P101)

Filed: July 10, 2001
Group Art Unit: 1765

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Transmittal Letter (1 page);
- (2) Response to Office Action (9 pages).

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Brian D. Ogonowsky

Carmen C. Cook

David C. Hsia

Rachel V. Leiteman

October 15, 2003

Via Facsimile

Mail Stop Non-Fee Amendment
 Commissioner for Patents
 P. O. Box 1450
 Alexandria, VA 22313-1450

Re: Applicant(s): Kirk Martin
 Assignee: Niscnc Technology Group
 Title: Method and Apparatus for Etching a Semiconductor Die
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OFFICIAL

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) This Transmittal Letter (1 page);
- (2) Response to Office Action (9 pages).

- ☒ No additional fee is required.
☐ The fee has been calculated as shown below:

| | Claims Remaining After Amendment | | Highest No. Previously Paid For | | Percent Extra | Rate | | Additional Fee |
|-------------------------------------|--|-------|---------------------------------------|---|------------------|--------|----|-------------------|
| Total Claims | 26 | Minus | 35 | = | 0 | x \$9 | \$ | 0.00 |
| Independent Claims | 3 | Minus | 6 | = | 0 | x \$43 | \$ | 0.00 |
| <input type="checkbox"/> | Fee of _____ for the first filing of one or more multiple dependent claims per application | | | | | | | \$ |
| <input checked="" type="checkbox"/> | Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested. | | | | | | | |
| <input type="checkbox"/> | Please charge our Deposit Account No. 502226 in the amount of | | | | | | | 0.00 |
| <input checked="" type="checkbox"/> | Also, charge any additional fees required and credit any overpayment to our Deposit Account No. 502226. | | | | | | | |
| Total: | | | | | | | \$ | <u>0.00</u> |

| Certification of Facsimile Transmission | |
|---|---------------|
| I hereby certify that this paper is being facsimile transmitted to the U.S. Patent and Trademark Office on the date shown below. | |
| | Oct. 15, 2003 |
| Signature | Date |

Respectfully submitted,

Carmen C. Cook
 Attorney for Applicant(s)
 Reg. No. 42,433

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kirk Martin
Assignee: Nisene Technology Group
Title: Method and Apparatus for Etching a Semiconductor Die
Serial No.: 09/902,931 Filing Date: July 10, 2001
Examiner: Vinh, Lan Group Art Unit: 1765
Docket No.: M-11706 US
(NTG-P101)

San Jose, California
October 15, 2003

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action mailed July 30, 2003, Applicant submits the following amendments and remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.

PATENT LAW
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